

➤ Aim and Themes

Micro/meso-scale (between macro and micro) manufacturing has been developed in research fields of machining, forming, materials and others, but application to industrial products is not sufficient. The main objective of this forum is to bring together the possibility from academic research and the needs of industries as much as possible. This forum consists of paper sessions, group discussions, a panel discussion and a symposium for matching state-of-the-art technologies and needs. The exhibition of the achievement of industrial products is also planned to encourage the participants to touch concrete shape and function. In addition to seek for practical use, pure scientific approach is welcome in the paper sessions for understanding of various technological fields.

Topics covered are:

- Microfactory Concepts and Micro-manufacturing Applications
- Micromachining
- Micro forming
- Micro-EDM and others
- Materials for Micro manufacturing
- Tribology and Surface Engineering in Micro manufacturing

➤ Important Dates

Submission deadline of abstract	February 28, 2010
Notification of abstract acceptance	March 31, 2010
Submission deadline of full paper	June 30, 2010
Notification of final paper acceptance	August 15, 2010
Final Early Bird Registration	August 31, 2010
Public Final Registration	September 15, 2010

➤ Call for papers

Abstract

Please prepare abstract with no figures as a MS-Word (.doc) file. An abstract of 200-250 Words in English is expected, structured as follows: Title / Author(s) / corresponding author's address / E-mail address / 3-4 keyword / Abstract's text
Please send the abstract file to contact@ifmm10.org with the title of "IFMM10 Abstract".

Full paper

Please prepare up-to 6 pages full paper in A4 or US-letter size as a PDF file. Please send the full-paper file to contact@ifmm10.org with the title of "IFMM10 Full Paper".

➤ About publications

Since the copyrights for the papers remain with the authors, the authors are free to also consider submitting their paper either in its original or in extended form to a journal for publication. Possible journals include but are not limited to:

- (1) Transactions of ASME: Journal of Manufacturing Science and Engineering (<http://journaltool.asme.org>)
- (2) SME: Journal of Manufacturing Processes (http://www.elsevier.com/wps/find/journaldescription.cws_home/620379/description)

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➤ IFMM'10 Secretariat

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➤ Provisional Program

Early Day Program - Wednesday 20 October, 2010

- Registration and Discussion on Micro Manufacturing

Day I - Thursday 21 October 2010

- Registration
- Opening Ceremony
- Paper Session
- Welcome Reception

Day II - Friday 22 October 2010

- Paper Session
- Group Discussion and Panel Discussion
- Banquet

Day III - Saturday 23 October 2010

- Symposium on Micro Manufacturing (Plenary Lectures)
- Closing Ceremony

Optional Program

- Sunday 24 and Monday 25 October, 2010

- Industry Tour
(If there are some requirements, the plan will be made)

➤ Conference Fees

Category	Before August 31	After September 1
Participants	JPY60,000	JPY70,000
Students	JPY30,000	JPY40,000
Accompanying Person	JPY20,000	JPY30,000
Participants (Day III only)	JPY20,000	JPY30,000

➤ About Gifu City

Nagoya area stretches beyond the central city of Nagoya to other municipalities in Aichi Prefecture, as well as neighboring Gifu and Mie prefectures. This area is Japan's third most populous metropolitan and industrial area after the Greater Tokyo Area and Osaka-Kobe-Kyoto.

Gifu City is located in the center of Japan. Although Gifu City is located in the south-central portion of Gifu Prefecture and serves as the prefectural capital, it is blessed with an environment full of natural beauty; the Nagara River running through the center of the city has clear water, and Mt. Kinka is rich in greenery.

Gifu is easily accessible both domestically and for travellers coming from abroad. Gifu can be reached by train in 20 minutes from Nagoya, 1 hour from Central Japan International Airport (CENTRAIR), 2 hours from Tokyo, and 1 hour from Osaka.

Gifu City is well known as a historical city with UKAI (cormorant fishing) in the pristine Nagara River—a tradition with some 1300 years of history. It is also famous for Gifu Castle, a central landmark in the history of 16 century daimyō general ODA Nobunaga.

Gifu City was also approved as an international convention city in 1988, and has continued to grow in popularity as an international convention and tourism city ever since.



IFMM'10

Gifu, JAPAN

October 20-23, 2010

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